

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:)
	Tetsuro Inui et al.))
Serial No.	10/624,082))
Filing Date:	July 21, 2003))
Confirmation No.:	5995))
For:	DISPERSION MONITORING METHOD AND APPARATUS AND DISPERSION SLOPE TEMPERATURE DEPENDENCY COMPENSATION METHOD AND APPARATUS))))

PRELIMINARY AMENDMENT

Commissioner for Patents PO Box 1450 Arlington, Virginia 22313-1450

Sir:

Prior to examination of the above-identified patent application, please enter the following amendments.